

3-19-02  
J1000 U.S. PTO  
10/05/2002  
01/24/02  


## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of )  
Hideto OHNUMA )  
Japanese Priority Application No. 2001-019293 ) Attn: Applications  
Japanese Priority Date: January 26, 2001: ) Branch  
For: METHOD OF MANUFACTURING )  
SEMICONDUCTOR DEVICE ) Date: January 24, 2002

INFORMATION DISCLOSURE STATEMENT

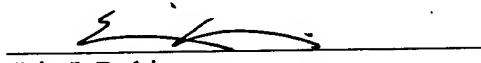
Honorable Commissioner for Patents and Trademarks  
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

Copies of these references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,

  
Eric J. Robinson  
Registration No. 38,285

NIXON PEABODY LLP  
8180 Greensboro Drive, Suite 800  
McLean, Virginia 22102  
(703) 790-9110